



IFW/1762

Electronic Filing System (EFS) Data
Electronic Patent Application Submission
USPTO Use Only

EFS ID: 62087
Application ID: 10814768
Title of Invention: A METHOD FOR PROCESSING A
SUBSTRATE
First Named Inventor: Kazuhito Nakamura
Domestic/Foreign Application: Domestic Application
Filing Date: 2004-03-31
Effective Receipt Date: 2004-06-04
Submission Type: Information Disclosure
Statement
Filing Type:
Confirmation number: 8865
Attorney Docket Number: RAJ018



Total Fees Authorized:

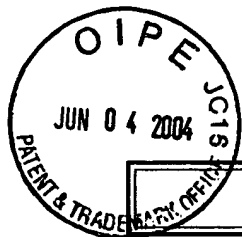
Digital Certificate Holder: cn=Kristi Lynn Davidson,ou=Registered Attorneys,ou=Patent and
Trademark Office,ou=Department of Commerce,o=U.S. Government,c=US
Certificate Message Digest: 78bd655862147206cd8aac460efa27ea3cd23aa2

**TRANSMITTAL**

Electronic Version v1.1

Stylesheet Version v1.1.0

Title of Invention	A METHOD FOR PROCESSING A SUBSTRATE	
Application Number: 10/814768 Date: 2004-03-31 First Named Applicant: Kazuhito Confirmation Number: 8865 Attorney Docket Number: RAJ018		
<p>I hereby certify that the use of this system is for OFFICIAL correspondence between patent applicants or their representatives and the USPTO. Fraudulent or other use besides the filing of official correspondence by authorized parties is strictly prohibited, and subject to a fine and/or imprisonment under applicable law.</p> <p>I, the undersigned, certify that I have viewed a display of document(s) being electronically submitted to the United States Patent and Trademark Office, using either the USPTO provided style sheet or software, and that this is the document(s) I intend for initiation or further prosecution of a patent application noted in the submission. This document(s) will become part of the official electronic record at the USPTO.</p>		
Submitted by:	Elec. Sign.	Sign. Capacity
Kristi Lynn Davidson Registered Number: 44643	Kristi L. Davidson	Attorney
Documents being submitted us-ids		Files RAJ018-usidst.xml us-ids.dtd us-ids.xsl
Comments		



ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

A METHOD FOR PROCESSING A SUBSTRATE

Application Number: 10/814768
Confirmation Number: 8865
First Named Applicant: Kazuhito Nakamura
Attorney Docket Number: RAJ018
Search string: (6610568 or

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6610568	2003-08-26	Marsh et al.	B2	438	250

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

init	Cite.No.	Pub. No.	Date	Applicant	Kind	Class	Subclass
	1	20030129306	2003-07-10	Wade et al.	A1	427	255.28

Remarks

Note: Remarks are not for responding to an office action.

In accordance with the duty of candor and good faith imposed by 37 C.F.R. 1.56 and means of complying therewith according to 37 C.F.R. 1.97 and 1.98, the references listed on this Information Disclosure Statement are called to the attention of the United States Patent and Trademark Office in connection with the above-identified patent application. No representation is made that the cited art is the only art or that the cited art represents the best art. The Examiner is urged to consider all of the cited documents and to make an independent evaluation of the teachings and materiality of each. If any additional fees are necessary to complete this communication, please apply them to Deposit Account No. 23-3000.



Signature

Examiner Name	Date